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## APPLICANTS

Koichiro Saga, Kanagawa, JAPAN;

## \*\* CONTINUING DATA \*\*\*\*\*

This application is a 371 of PCT/JP03/00938 01/30/2003

## \*\* FOREIGN APPLICATIONS \*\*\*\*\*

JAPAN 2002-021097 01/30/2002

Foreign Priority claimed 35 USC 119 (a-d) conditions met	<input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance	STATE OR COUNTRY JAPAN	SHEETS DRAWING 7	TOTAL CLAIMS 41	INDEPENDENT CLAIMS 13
Verified and Acknowledged	Examiner's Signature _____ Initials _____				

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## TITLE

Surface treatment method, semiconductor device, method of fabricating semiconductor device, and treatment apparatus

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